

## THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 1393

Takashi TANAKA ET AL.

Docket No. 2001\_1507A

Serial No. 09/970,621

Group Art Unit 3723

Filed October 5, 2001

Examiner Lee D. Wilson

METHOD FOR SUPPLYING SLURRY TO POLISHING APPARATUS

**AMENDMENT** 

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY OF THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action mailed April 18, 2003, please amend the above-identified application as follows:

07/21/2003 RADOF01 00000026 09970621 01 FC:1201 84.00 GP

## **AMENDMENTS TO THE SPECIFICATION AND ABSTRACT:**

Please replace the original specification and abstract with the enclosed substitute specification and abstract.